



## **Fugitive methane emission pinpointing and source attribution using ethane measurements in a portable cavity ring-down analyzer**

Derek Fleck, John Hoffnagle, John Yiu, Johnston Chong, and Sze Tan  
Picarro Inc, Santa Clara, CA , USA (dfleck@picarro.com)

Methane source pinpointing and attribution is ever more important because of the vast network of natural gas distribution which has led to a very large emission sources. Ethane can be used as a tracer to distinguish gas sources between biogenic and natural gas. Having this measurement sensitive enough can even distinguish between gas distributors, or maturity through gas wetness. Here we present data obtained using a portable cavity ring-down spectrometer weighing less than 11 kg and consuming less than 35W that simultaneously measures methane and ethane with a raw  $1-\sigma$  precision of 50ppb and 4.5ppb, respectively at 2 Hz. These precisions allow for a  $C_2:C_1$  ratio  $1-\sigma$  measurement of  $<0.1\%$  above 10ppm in a single measurement. Utilizing a second onboard laser allows for a high precision methane only mode used for surveying and pinpointing. This mode measures at a rate faster than 4Hz with a  $1-\sigma$  precision of  $<3$ ppb. Because methane seepages are highly variable due to air turbulence and mixing right above the ground, correlations in the variations in  $C_2H_6$  and  $CH_4$  are used to derive a source  $C_2:C_1$ . Additional hardware is needed for steady state concentration measurements to reliably measure the  $C_2:C_1$  ratio instantaneously. Source discrimination data of local leaks and methane sources using this analysis method are presented. Additionally, two-dimensional plume snapshots are constructed using an integrated onboard GPS to visualize horizontal plane gas propagation.